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Enid.

layering a second conductive material over said first conductive material.

Sub D2
44. (Amended) The method in claim 43, wherein said step of releasing nitrogen from said plasma with electromagnetic energy comprises ~~directing~~ ultraviolet light toward said gas.

Sub D3
76. (Amended) A method of passivating a multilayer conductive structure, comprising:
layering a first conductive material;
introducing N_2 plasma to said first conductive material;
releasing nitrogen from said plasma with electromagnetic energy;
and
layering a second conductive material over said first conductive material.

77. (Amended) A method of passivating a multilayer conductive structure, comprising:
layering a first conductive material;
introducing NH_3 plasma to said first conductive material;
releasing nitrogen from said plasma with electromagnetic energy;
and
layering a second conductive material over said first conductive material.